

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KIRA, et al.

Serial Number: 08/897,953

Filed: July 24, 1997

For: METHOD AND SYSTEM FOR FABRICATING SEMICONDUCTOR DEVICE



Group Art Unit: 2814

Examiner: D. Graybill

RESPONSE UNDER 37 C.F.R. §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 2814

BOX AF

Director of Patents and Trademarks
Washington, D. C. 20231

May 1, 2000

Sir:

In response to the Office Action dated November 30, 1999, extended to April 30, 2000 by a two (2) month Petition for Extension of Time, please amend the above-captioned patent application as follows:

IN THE CLAIMS:

Cancel claims 4 and 11-14.

Amend claims 5 and 6 as follows:

Claim 5, line 2, delete "11 or".

RECEIVED
TC 2800 MAIL ROOM
MAY 5 2000